

Docket No.: 60188-625

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	
	:	
Hisashi OGAWA, et al.	:	
	:	
Serial No.: Divisional of	:	
Application Serial No. 10/196,229	:	Group Art Unit: Not yet assigned
	:	
Filed: September 08, 2003	:	Examiner: Not yet assigned
	:	
For: SEMICONDUCTOR MEMORY AND METHOD FOR FABRICATING THE SAME		

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows:

Please amend the specification as reflected in "Amendment to the Specification" on page 2 of this preliminary amendment.